

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Shimizu, et al.
Appl. No.	:	10/618,900
Filed	:	July 14, 2003
For	:	SINGLE-WAFER-PROCESSING TYPE CVD APPARATUS
Examiner	:	Rudy Zervigon
Group Art Unit	:	1763

AMENDMENT AFTER FINAL**Mail Stop: AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed October 19, 2006, please reconsider the present application in light of the following amendments and comments.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.